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SECTOR #

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: TAMAKI KOBAYASHI ET AL.	<pre>) : Examiner: Not Assigned) : Group Art Unit: 2879</pre>
Application No.: 09/440,535)
Filed: November 16, 1999	;)
For: SUBSTRATE FOR ELECTRON SOURCE, ELECTRON SOURCE AND IMAGE FORMING APPARATUS, AND MANUFACTURING METHOD THEREOF	:) :) : Date: February 29, 2000
Box Missing Part The Assistant Commissioner for Washington, D.C. 20231	Patents

ATTENTION: APPLICATION PROCESSING DIVISION, SPECIAL PROCESSING AND CORRESPONDENCE BRANCH

RESPONSE TO NOTICE TO FILE MISSING PARTS OF APPLICATION - FILING DATE GRANTED

Sir:

In response to the NOTICE TO FILE MISSING PARTS OF APPLICATION - FILING DATE GRANTED mailed December 29, 1999,

01 FC:105

130.00 00

I hereby certify that this correspondence is being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231 on February 29, 2000

(Date of Deposit)

Leonard P. Diana
(Name of Attorney for Applicant)

Signature

February 29, 2000
Date of Signature

enclosed please find an executed Declaration/Power of Attorney form, together with the surcharge fee of \$130.00.

The Assistant Commissioner is authorized to charge any additional fees or credit any overpayment to Deposit Account No. 06-1205. A duplicate copy of the document is attached for that purpose.

Applicants' undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should be directed to our new address given below.

Respectfully submitted,

Attorney for Applicants

Registration No. 8 46

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